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## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **OZAKI, Takashi, et al.**

Group Art Unit: 1792

Serial No.: **10/528,137**Examiner: **MACARTHUR, Sylvia**

Filed: December 12, 2005

P.T.O. Confirmation No.: 2307

FOR: **SUBSTRATE PROCESSING APPARATUS AND METHOD FOR  
MANUFACTURING A SEMICONDUCTOR DEVICE**

**RESPONSE UNDER 37 CFR §1.116**  
- EXPEDITED RESPONSE -  
**GROUP ART UNIT 1792**

**MAILSTOP AF**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

January 23, 2009

Sir:

In response to the Final Office Action dated October 2, 2008, extended from January 2, 2009 to February 2, 2009 by a one (1) month Petition for Extension of Time, please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 9 of this paper.

Entered  
by  
PCE  
3/11/09  
J